



**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Hiroshi MORIOKA**

Group Art Unit: 1756

Application Number: **10/692,722**

Examiner: **Daborah CHACKO-DAVIS**

Filed: **October 27, 2003**

Confirmation Number: **9699**

For: **MICRO PATTERN FORMING METHOD AND SEMICONDUCTOR DEVICE  
MANUFACTURING METHOD**

Attorney Docket Number: **032045**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Mail Stop Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

May 22, 2007

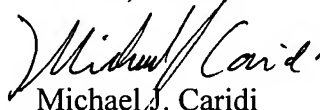
Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated January 26, 2007 for one month from April 26, 2007 to May 26, 2007.

Attached please find a check in the amount of \$120.00 for the cost of the extension. If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

  
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Enclosures: Check \$120.00